

**In the Drawings**

The second occurrence of "Fig. 3" should be changed to "Fig. 14(k)." The specification mentions that Fig. 3 and Fig. 14(k) are the same figure, and this amendment is required to correct a typographical error in labeling the figure. No new matter is introduced. The corrected drawings submitted with the Notice to File Corrected Application Papers reflect this change.

**Remarks**

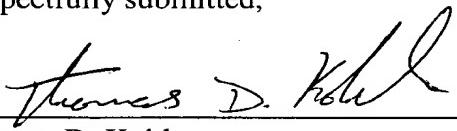
Applicants have amended the specification merely to correct simple typographical errors that would be clear to one skilled in the art. Accordingly, no new matter is believed to be introduced by this amendment, and Applicant respectfully requests entry of the amendments and remarks made herein in the file of the above-identified application.

**CONCLUSION**

Applicant estimates that no fee is due in connection with this Amendment. Should the Patent Office determine otherwise, The Commissioner is hereby authorized to charge any fees associated with filing this Amendment to Pennie & Edmonds LLP Deposit Account No. 16-1150. A copy of this sheet is enclosed.

Respectfully submitted,

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**EXHIBIT A:**  
**CHANGES TO SPECIFICATION**  
**UPON ENTRY OF THE PRELIMINARY AMENDMENT**  
**FILED DECEMBER 20, 2001**

**U.S. PATENT APPLICATION SERIAL NO. 09/960,585**  
**(ATTORNEY DOCKET NO. 10636-007-999)**

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*The following mark-up scheme is adopted:*

*Deleted material:* Strike-through.

*Inserted material:* Bold Underline

***The paragraph beginning at page 5, line 4 is revised as follows:***

Figs. 13(a) - (c)(e) is a flowchart illustrating a method according to the present invention; and

***The paragraph beginning at page 12, line 11 is revised as follows:***

Fig. 13(a) - (c)(e) is a flowchart of a preferred method for utilizing the dual wafer stage of the present invention. This flowchart illustrates a preferred method of utilizing dual wafer stage assembly 40 of the present invention. The flowchart further illustrates interferometer use during the movement of the stages. Individual steps in the flowchart are discussed in more detail in the referenced sub-illustrations of Fig. 3 and Fig. 14(a) - (v).